

<b>LIST OF ART CITED BY APPLICANT (PTO-1449)</b>	<b>ATTY. DOCKET NO.</b> <b>P-0609</b>	<b>APPLN. SERIAL NO.</b> <b>10/695,737</b>
	<b>APPLICANT(S)</b> <b>Min-Jung KIM and Seung-Hoon HWANG</b>	
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**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

**U.S. PATENT APPLICATION PUBLICATIONS**

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS

**U.S. PATENT APPLICATIONS**

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS

**FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation Yes      No
	1020020038206A	05/23/2002	Korea (English Abstract & full Korean text)			X
	CN1256031	06/07/2000	China (English Abstract & full Chinese text)			X

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)**

Chinese Office Action, dated January 25, 2008

EXAMINER	/Steven Lim/	DATE CONSIDERED	06/22/2010
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EXAMINER. Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /S.L./